



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
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Bib Data Sheet

CONFIRMATION NO. 8690

<b>SERIAL NUMBER</b> 09/761,738	<b>FILING DATE</b> 01/18/2001 <b>RULE</b>	<b>CLASS</b> 118	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> 202009US-2 DIV
<b>APPLICANTS</b> Shigenobu Maeda, Tokyo, JAPAN;				
<b>** CONTINUING DATA *****</b> THIS APPLICATION IS A DIV OF 09/349,514 07/09/1999 PAT 6,231,673				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN P11-14303 01/22/1999				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/25/2001</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> Allowance Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 36	<b>TOTAL CLAIMS</b> 4
<b>INDEPENDENT CLAIMS</b> 1				
<b>ADDRESS</b> 22850				
<b>TITLE</b> Manufacturing method of semiconductor wafer, semiconductor manufacturing apparatus, and semiconductor device				
<b>FILING FEE RECEIVED</b> 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	



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SERIAL NUMBER 09/761,738	FILING DATE 01/18/2001  RULE	CLASS 438	GROUP/ART UNIT 2824	ATTORNEY DOCKET NO. 202009US-2 DIV
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## APPLICANTS

Shigenobu Maeda, Tokyo, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/349,514 07/09/1999 PAT 6,231,673

*MR*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P11-14303 01/22/1999

*MSL*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/25/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 36	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials	

## ADDRESS

22850  
OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.  
1940 DUKE STREET  
ALEXANDRIA, VA  
22314

## TITLE

MANUFACTURING METHOD OF CIRCUIT ELEMENTS ON A SEMICONDUCTOR WAFER USING A  
PLURALITY OF MASKS

FILING FEE  RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )



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